



Appl. No. : 10/607,276  
Applicant : Seokhyun LIM  
Filed : June 27, 2003  
TC/A.U. : 3752  
Examiner : Patrick F. Brinson

Confirmation No. 4717

Docket No. : 1751-340  
Cust. No. : 06449

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith copies of two publications that the Office may wish to consider in examination of the subject application. The publication is listed on the attached Form PTO-1449.

Please charge the \$180.00 cost thereof under 37 C.F.R. § 1.17(p) to deposit account no. 02-2135. An extra copy of this letter is attached.

Respectfully submitted,

By

Thomas E. McKiernan  
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1751-340-ids

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				<i>Complete if Known</i>	
				Application Number	10/607,276
				Filing Date	June 27, 2003
				First Named Inventor	Seokhyun LIM
				Group Art Unit	3752
				Examiner Name	Patrick F. Brinson
Sheet	1	of	1	Attorney Docket Number	1751-340
<b>NON PATENT LITERATURE DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			T <sup>2</sup>
	A	LIM, S. & CHOI, H. 2003; "Optimal Shape Design of Pressure-driven Curved Micro Channels with Hydrophilic and Hydrophobic Walls"; Nanotech 2003, San Francisco, CA USA, Feb. 23-27, 2003 (vol. 1, pp. 170-173).			
	B	LIM, S. & CHOI, H. 2004; "Optimal Shape Design of a Pressure-driven Curved Micro Channel"; 42nd AIAA Aerospace and Sciences Meeting and Exhibit, Reno, NV USA, Jan. 5-8, 2004, AIAA-2004-624.			
Examiner Signature				Date Considered	

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.